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Docket No.: INTECH 3.0-081
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ramachandran et al.

Application No.: Not Yet Assigned

Group Art Unit: N/A

Filed: Herewith

Examiner: Not Yet Assigned

For: SEMICONDUCTOR DEVICE CLEANING EMPLOYING HETEROGENOUS NUCLEATION FOR CONTROLLED CAVITATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

It is respectfully requested that the references listed on the enclosed form be made of record and considered with respect to the above-referenced U.S. patent application. A copy of each reference is enclosed. Submission of the present Information Disclosure Statement should not be taken as an admission that the cited references are legally available prior art or that the same are pertinent or material.

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Dated: October 15, 2003

Respectfully submitted,

By _____

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 1

Complete if Known	
Application Number	Not Yet Assigned
Filing Date	Concurrently Herewith
First Named Inventor	Ravikumar Ramachandran
Art Unit	N/A
Examiner Name	Not Yet Assigned
Attorney Docket Number	INTECH 3.0-081 Infineon Ref. No. 02P15180US

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	Document Number Number-Kind Code[2] (*if known*)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	AA	5,681,396	10-28-1997	Madanshetty	
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Examiner Initials*	Cite No.[1]	Foreign Patent Document Country Code[3]-Number[4]-Kind Code[5] (*if known*)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T[6]

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.[1]	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T[2]
	CA	Damage Due to Spot Cavitation on Hemispherical Cylindrical Body (Comparison between Isolated Cavity and Parallel Cavities), Seiji Shimizu, Akihiro Ihara, Motoo Okada and Motoyasu Sakurai, Hiroshima Institute of Technology, CAV2001: Session A3.004, pages 1-8, 2001. Retrieved from Internet <URL:cav2001.library.caltech.edu/archive/00000345/00/Spot_Cavitation_2001(full_paper_with_figures). pdf>.	
	CB	The Dynamics and Thermodynamics of Phase Transformations, Department of Mechanical and Materials Engineering Materials, Engineering 203/ Materials Chemistry 204 Laboratory Notes, Semester 1, 2002, pages 1-2.	
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